520.43279X00

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OCT O 7 2004 E

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

S. YAMASHITA, et al

Serial No.:

10/706,972

Filed:

November 14, 2003

For:

QUALITY MONITORING SYSTEM FOR BUILDING STRUCTURE, QUALITY MONITORING METHOD FOR BUILDING STRUCTURE AND SEMICONDUCTOR

INTEGRATED CIRCUIT DEVICE

Group:

2857

Examiner:

## INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 & 1.98

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

October 7, 2004

Sir:

In the matter of the above-identified application, applicant(s) is/are submitting herewith a copy of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

This information disclosure statement is being submitted before the mailing date of a first office action on the merits.

To the extent that, the documents listed on the attached form equivalent to Form PTO-1449, are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by an English language abstract.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (520.43279X00) and please credit any excess fees to such deposit account.

Respectfully submitted,

Melvin Kraus

Registration No. 22,466

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Form PTO-1449 Equivalent U.S. Department of Commerce Patent and Trademark Office

Atty. Docket No. 520.43279X00 Serial No. 10/706,972 Applicant: YAMASHITA et al Filing Date: November 14, 2003

Group: 2857

## **U.S. Patent Documents**

Examiner Initials	Document No.	Date	Name	Class Subclass	Filing Date If Approp.

## **Foreign Patent Documents**

	Country		Class Subclass	Translation Yes No
11/93	Japan	en.		(abstract)
	11/93 3/96	11/93 Japan	11/93 Japan	11/93 Japan

Other Documents (including Author, Title, Date, Pertinent Pages, etc.)

Examiner

**Date Considered** 

<sup>\*</sup>Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.